



PATENT  
0020-4921P  
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IN THE U. S. PATENT AND TRADEMARK OFFICE

Applicants: M. OHTA Conf.: 8299  
Appln. No.: 09/994,673 Art Unit: 1762  
Filed: November 28, 2001 Examiner: T. H. MEEKS  
For: METHOD FOR EVENLY COATING SEMICONDUCTOR  
LASER END FACES AND FRAME USED IN THE  
METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 29, 2003

Sir:

In response to the Office Action dated August 28, 2003, the period for reply petitioned to be extended one month herein to December 28, 2003 (the first business day following the holiday being December 29, 2003), the following amendments and remarks are respectfully submitted in connection with the above-identified application as follows:

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper

Remarks/Arguments begin on page 5 of this paper.